



Attorney's Docket No. 051876P232

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Won-Ick Jang, et al.

Serial No. 09/753,065

Filed: 12-23-2000

For: **STICTION-FREE MICROSTRUCTURE
RELEASED METHOD FOR
FABRICATING MEMS DEVICE**

RECEIVED

DEC 16 2003

TC 1700

Examiner: Lan Vinh

Art Unit 1765

Confirmation No. 9323

PETITION FOR EXTENSION OF TIME

AND

AMENDMENT AND RESPONSE TO OFFICE ACTION

Mail Stop Fee Amendments
Commissioner for Patents
Post Office Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

In response to the Office Action mailed June 5, 2003, Applicants respectfully request entry of the following amendments.

12/10/2003 AOSMAN1 00000038 09753065

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